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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

SUPPLEMENTAL INFORMATION DISCLOSURE

STATEMENT BY APPLICANTS

ATTY. DOCKET NO. APPLN. NO. UV-43 09/034,934

**APPLICANTS** Michael D. Ellis et al. CONFIRMATION. NO. 4014

**FILING DATE** March 4, 1998 **GROUP ART** 

2611

## **U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
W	4,081,753	03/28/78	Miller	325	396	
	4,170,782	10/09/79	Miller	358	84	
	4,271,532	06/02/81	Wine	455	186	
	4,367,559	01/04/83	Tults	455	186	
	4,375,651	03/01/83	Templin et al.	358	191.1	
	4,381,522	04/26/83	Lambert	358	86 <b>R</b>	ECEIVED
-	4,390,901	06/28/83	Keiser	358	147	10V 2 6 2003
	4,425,579	01/10/84	Merrell	358	180	
	4,429,385	01/31/84	Cichelli et al.	370	92 Tech	hology Center 260
	4,495,654	01/22/85	Deiss	455	151	37
	4,527,194	07/02/85	Sirazi	358	86	
	4,641,205	02/03/87	Beyers, Jr.	360	33.1	
	4,689,022	08/25/87	Peers et al.	434	307	
	4,754,326	06/28/88	Kram et al.	364	900	
	4,908,713	03/13/90	Levine	358	335	
	4,963,994	10/16/90	Levine	358	335	
	5,038,211	08/06/91	Hallenbeck	358	142	
	5,047,867	09/10/91	Strubbe et al.	358	335	
	5,075,771	12/24/91	Hashimoto	358	84	
	5,210,611	05/11/93	Yee et al.	358	191.1	
	5,317,403	05/31/94	Keenan	348	731	
	5,323,240	06/21/94	Amano et al.	348	731	
	5,432,561	07/11/95	Strubbe	348	565	
	5,444,499	08/22/95	Saitoh	348	734	
	5,465,385	11/07/95	Ohga et al.	455	6.1	
	5,477,262	12/19/95	Banker et al.	348	7	
	5,481,296	01/02/96	Cragun et al.	348	13	
+	5,483,278	01/09/98	Strubbe et al.	725	61	

EXAMINER

**DATE CONSIDERED** 

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APPLICANTS Michael D. Ellis et al.	CONFIRMATION. NO. 4014
FILING DATE March 4, 1998	GROUP ART 2611

		07/00/00		h40			
//	5,534,911	07/09/96	Levitan	348	1		
	5,600,364	02/04/97	Hendricks et al.	348	1		
	5,617,565	04/01/97	Augenbraum, et al.	395	604		
	5,621,456	04/15/97	Florin et al.	348	7		
	5,694,176	12/02/97	Bruette et al.	348	563		
	5,731,844	03/24/98	Rauch et al.	348	563		
	5,752,160	05/12/98	Dunn	455	5.1		
,	5,774,357	06/30/98	Hoffberg et al.	364	188	!	
	5,801,747	09/01/98	Bedard	348	1		
	5,822,123	10/13/98	Davis et al.	348	564	_RE	CEIVED
	5,848,396	12/08/98	Gerace	705	10		
	5,867,226	02/02/99	Wehmeyer	725	46	NC	V 2 6 2003
	5,880,768	03/09/99	Lemmons et al.	348	11	Tachac	lacu Contar 9600
	5,903,545	05/11/99	Sabourin, et al.	370	225	rechilo	logy Center 2600
	6,075,526	06/13/00	Rothmuller	345	327		
	6,088,722	06/11/00	Herz et al.	709	217		
	6,216,264	04/10/01	Maze et al.	725	53		
	6,437,836	08/20/02	Huang et al.	348	734		
	6,505,348	01/07/03	Knowles et al.	725	49		
	·						

## **FOREIGN PATENT DOCUMENTS**

EXAMINER	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
INITIAL	NUMBER					YES	NO
V	1 554 411	10/17/79	GB	H04B	3/54		
	EP 0 774 866 A2	05/21/97	EPO	H04N	5/44		
	WO 86/01359	02/27/86	PCT	H04N	5/445		
	WO 89/03085	04/06/89	РСТ	G06F	7/04		-
	WO 94/13107	06/09/94	PCT	H04N	7/16		
	WO 95/287 <b>9</b> 9	10/26/95,	PCT	H04N	1/00		

**EXAMINER** 

DATE CONSIDERED

7/24/07

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APPLN. NO.



**FORM PTO-1449** 

U.S. DEPARTMENT OF COMMERCE

PATENT AND TRADEMARK OFFICE

ı	UV-43	09/034,934
	APPLICANTS	CONFIRMATION. NO.
	Michael D. Ellis et al.	4014

ATTY. DOCKET NO.

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STATEMENT BY APPLICANTS

**FILING DATE GROUP ART** March 4, 1998 2611

(2)	WO 96/17473	06/06/96	PCT	H04N	5/445			
	WO 96/41478	12/19/96	PCT	H04N	7/173			
	WO 98/26584	06/18/98	РСТ	H04N	5/445			
	WO 98/48566	10/29/98	PCT	H04N	5/445			
	WO 99/01984	01/14/99	PCT	H04N	7/173			
	WO 99/45701	09/10/99	PCT	H04N	5/445			
	WO 00/04708	01/27/00	PCT	H04N	5/445	DE	CEN	
	WO 00/05889	02/03/00	PCT	H04N	7/16	111		
1	WO 00/28734	05/18/00	PCT	H04N	5/445	- N(	DV 267	2003
	WO 99/14947	02/28/02	РСТ	H04N	5/445			
						Techno	plogy Ce	hter 2600
					ĺ.			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL	

All references have been considered.

Examiner

**EXAMINER** 

**DATE CONSIDERED** 

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